

IN THE CLAIMS:

Please amend claim 1 as follows:

1. (Currently Amended) A method of manufacturing an electronic device comprising the steps of:

(a) forming, on an underlying layer, an insulating film made from one of an oxide film, a nitride film, an oxide nitride film, an organic film and an organic-inorganic hybrid film;

(b) forming a resist pattern on said insulating film;

(c) forming an insulating film pattern by etching said insulating film with said resist pattern used as a mask;

(d) conducting a plasma treatment on exposed portions of said underlying layer and said insulating film pattern without removing said resist pattern after the step (c); and

(e) forming a pattern for said underlying layer by etching said underlying layer with said resist pattern and said insulating film pattern used as a mask after the step (d).

2. (Original) The method of manufacturing an electronic device of Claim 1,

wherein said plasma treatment is conducted by using a gas including at least one of a N₂ gas, an O₂ gas and an inert gas in the step (d).

Claims 3-32 (Withdrawn)

REMARKS

The Official Action dated April 7, 2003 has been received and its contents carefully noted. In view thereof, claim 1 has been amended in order to better define that which Applicants regard as the invention. As previously, claims 1-32 are presently pending in the instant application, with claims 3-32 being withdrawn from further consideration by the Examiner as being directed to a non-elected invention.

With reference now to the Official Action, and particularly page 2 thereof, Applicant hereby acknowledges the election without traverse of claims 1 and 2 in connection with the present application.

With reference to the Official Action, dated April 7, 2003, Applicant hereby acknowledges that claims 3-32

pertaining to the invention are not being pursued. The present application is hereby amended to reflect the set forth by Applicants' claimed invention.

Specifically, as can be seen from the foregoing amendments, independent claim 1 has been